



2827

IN THE UNITED STATES PATENT AND TRADEMARK OFFICEIn re **PATENT** application of:

Applicant(s): Paul A. Kohl et al.

Serial No: 09/717,567

Filing Date: November 21, 2000

Title: FABRICATION OF A SEMICONDUCTOR DEVICE WITH AIR GAPS
FOR ULTRA-LOW CAPACITANCE INTERCONNECTIONS

Examiner: James M. Mitchell

Art Unit: 2827

Docket No. BFGBP0217USA

STATUS INQUIRYCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

A response to the Office Action dated December 18, 2002 was filed May 19, 2003 and received at the USPTO on May 22, 2003. Please advise as to the current status for the above-identified patent application.

Respectfully submitted,

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I hereby certify that this correspondence (along with any paper referenced as being attached or enclosed) is being deposited on the below date with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: 11-21-03

Jennifer A. Moore